Dissemination and Publicity Projects

This session focused on the latest dissemination and publicity activities conducted by the Micromachine Center and the Beans Laboratory.

1. Meeting of the Dissemination and Publicity

The first meeting of the Dissemination and Publicity Committee for FY 2009 was held on June 3. The committee reviewed the dissemination and publicity activities of the Micromachine Center for the current fiscal year and approved the schedule of activities.

The Center's Commercialization and Publicrelations Department also makes information available on its Web site to in an effort to publicize the achievements of national projects and stimulate MEMS industries.

2. Information-providing Activities

(1) Publication of Quarterly Magazine "MICRONANO"

Beginning this fiscal year, MICRONANO is being published jointly under the name of both the Micromachine Center and the BEANS Laboratory. Each issue covers the status and achievements of project activities as well as upcoming projects and events.

- Japanese edition (MICRONANO)
 Published quarterly and distributed in print form as well as in electronic form on the Center's Web site
- English edition (MICRONANO) (English translation of Japanese magazine)

Published quarterly in electronic form on the Center's Web site

(2) MMC-MIF-BEANS Monthly

Starting this fiscal year, MMC-MIF-BEANS Monthly is being published jointly by the Micromachine Center and the BEANS Laboratory. The monthly newsletter covers the status of activities, policy trends, information on upcoming events and so on.

(3) MicroNano Net

This occasional bulletin is published via mailing list and sent to supporting members of the Micromachine Center, MEMS Industry Forum members and so on. It provides information on MicroNano-related industry-academic joint activities and upcoming events.

(4) MEMS Mall

Since April 2009, not only MEMS Industry Forum members but also general companies have been able to list products and technologies on the MEMS Mall. Access has been expanded in this manner in order to invite participation from more MEMS-

related companies and make the MEMS Mall a portal site for MEMS business.

(5) News Blog

A Blog entitled "MEMS Wave @ Micromachine Center" has been started on the Micromachine Center Web site to provide quick updates on the latest activities of the Micromachine Center. Please feel free to visit to the Blog.

URL: http://beanspj.cocolog-nifty.com/mems/

3. Dissemination of Domestic Project Achievements(1) MEMS-ONE Project

The MemsONE Support Center has taken the lead in holding training sessions and technology exchange seminars and so on to promote dissemination of the design tool "MemsONE®" achieved by the MEMS Open Network Engineering System of Design Tools (MEMS-ONE) Development Project (FY 2004 - 2006).

(2) Fine MEMS Project (MEMS System Development Center)

The Fine MEMS knowledge database and the MEMS equivalent circuit generator achieved as a result of the Highly Integrated Complex MEMS (Fine MEMS) Production Technology Development Project (FY 2006 - 2008) have been made available in the form of the "MEMSPedia" Web content on the Micromachine Center's Web site.

(3) BEANS Project (BEANS Laboratory)

Starting in FY 2009, the BEANS Laboratory became the implementing entity for the BEANS Project (FY 2008 - 2012). Accordingly, the Micromachine Center is participating in the BEANS Project as a member, providing appropriate personnel and financial support to ensure the success of the project.

(4) Other Activities

1)Micromachine Technology Project

The MMPJ Archive has been made available on the Micromachine Center's Web site. The MMPJ Archive organizes the achievements of the Micromachine Technology Research and Development Project (FY 1991 - 2000) in Web contents, enabling information to be retrieved as needed.

②Study Report Data Service (Research and Standardization Department)

The Information Service Activities page of the Micromachine Center's Web site contains a list of research reports published in 1997 and thereafter, and also provides these reports at cost.